

## MICRO-501 **MEMS** practicals I

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Cursus	Sem.	Type
Microtechnics	MA1, MA3	Opt.

Language of **English** teaching Credits Withdrawal Unauthorized Winter Session Semester Fall During the Exam semester Workload 60h Weeks 14 Hours 2 weekly Practical 2 weekly work Number of positions It is not allowed to withdraw from this subject after the

registration deadline.

#### **Summary**

Objective of this practical is to apply in specific experimental settings the knowledge acquired in various MEMS related class

#### Content

The practical is organized in several lab experiments.

The part I (winter semester) is dedicated to MEMS technology and MEMS simulation:

- Finite element simulation of MEMS
- Design of MEMS actuators
- · Fabrication of MEMS actuators
- · Caracterization of MEMS actuators
- Noise in sensors

The part 2 (spring smester) is dedicated to sensors:

- · capacitive accelerometer
- ISFET
- Glucose sensor
- piezoresistive pressure sensor
- Electrokinetic chip

#### **Keywords**

MEMS, FEM simulation, microsensors, microtechnology, microactuators, silicon micromachining

#### **Learning Prerequisites**

### **Recommended courses**

Capteurs, Advanced MEMS, Materials and technology of microfabrication, Modeling and simulation of microsystems, Nanotechnology, Flexible bioelectronics, Scaling laws in micro- and nanosystems

### **Learning Outcomes**

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By the end of the course, the student must be able to:

- Conduct an experiment
- Report on experiments

#### Transversal skills

• Demonstrate the capacity for critical thinking

## **Teaching methods**

Practicals suprevised by assistants

## **Expected student activities**

- Make the experiments
- use a lab notebook
- write a short report after each experiment

#### **Assessment methods**

• based on work in the lab, anwer to questions during experimental sessions and quality of the report

# Supervision

Office hours Yes Assistants Yes

## Resources

### **Moodle Link**

• https://go.epfl.ch/MICRO-501

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